

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Kimitaka MURASHITA

Serial No. 10/028,264

Group Art Unit: 2862

Confirmation No. 2737

Filed: December 28, 2001

Examiner: Scott A. Rogers

For: DISPLAY MEASURING METHOD AND PROFILE GENERATING METHOD

**AMENDMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed November 18, 2005, and having a period for response set to expire on February 18, 2006. A Petition for a two-month extension of time, together with the requisite fee for same, is submitted herewith, thereby extending the period for response to April 18, 2006.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.